

<b>Notice of References Cited</b>	Application/Control No. 10/820,624	Applicant(s)/Patent Under Reexamination HENTGES ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,433,507 A	07-1995	Chang, Chung L.	297/367
*	B	US-6,007,153 A	12-1999	Benoit et al.	297/378.12
*	C	US-6,152,533 A	11-2000	Smuk, Wojciech	297/341
*	D	US-6,231,101 B1	05-2001	Kamida et al.	296/63
*	E	US-6,341,820 B1	01-2002	Kimura et al.	297/378.13
*	F	US-6,464,299 B1	10-2002	Castagna, Stephane	297/378.12
*	G	US-2003/0080601 A1	05-2003	Charras et al.	297/378.12
*	H	US-6,659,557 B2	12-2003	Deptolla, Bernd	297/367
*	I	US-7,137,667 B2	11-2006	Habedank, Klaus-Dieter	297/378.12
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	W	
	X	

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